



Docket No.: 052775-0024

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
: Confirmation Number: 1716
Masahiro NAKAYAMA, et al. :
Application No.: 10/662,524 : Group Art Unit: 3723
: Examiner: Dung V. Nguyen
: Filed: September 16, 2003
:

For: CHAMFERED FREESTANDING NITRIDE SEMICONDUCTOR WAFER AND
METHOD OF CHAMFERING NITRIDE SEMICONDUCTOR WAFER

PETITION FOR EXTENSION OF TIME

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the time for response to the Office Action dated March 15, 2006, now due to expire June 15, 2006, be extended for one (1) month and set to expire on July 15, 2006.

Please charge the extension fee of \$120.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Bernard P. Codd
Registration No. 46,429

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01 FC:1251 120.00 DA

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Washington, DC 20005-3096
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Facsimile: 202.756.8087
Date: July 17, 2006

**Please recognize our Customer No. 20277
as our correspondence address.**